

The 6th International symposium on Negative Ions, Beams and Sources (NIBS'18)

3-7 September 2018 Budker INP



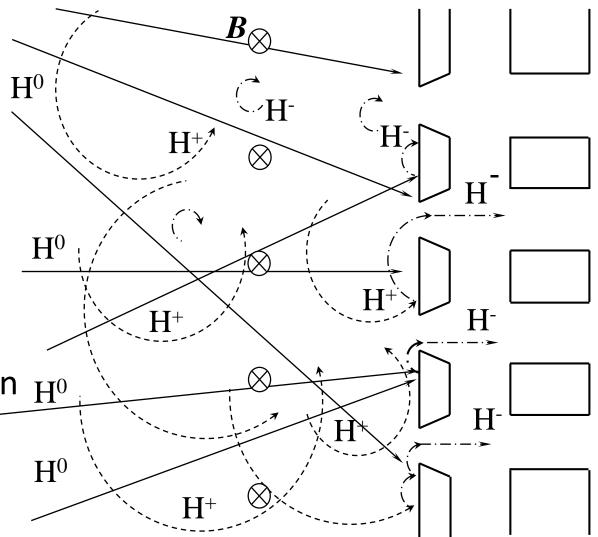
Effects of impurity ions upon Cs recycling in a negative hydrogen ion source

Motoi Wada

Doshisha University, Kyoto, Japan

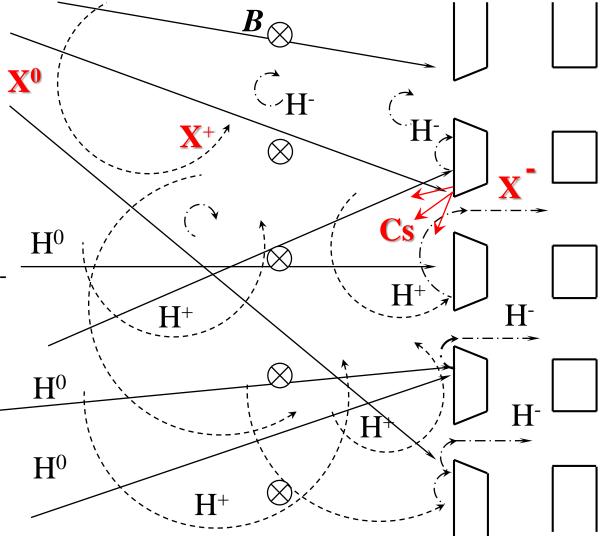
Extraction region of a H⁻ source

- Surface collision
 - Reflection
 - Desorption
 - Implantation
- Plasma-wall energy exchange
 - Thermalization
 - Collisions
 - Adsorption
 - Electron injection
- Sheath formation
 - Magnetic field
 - Potential profile



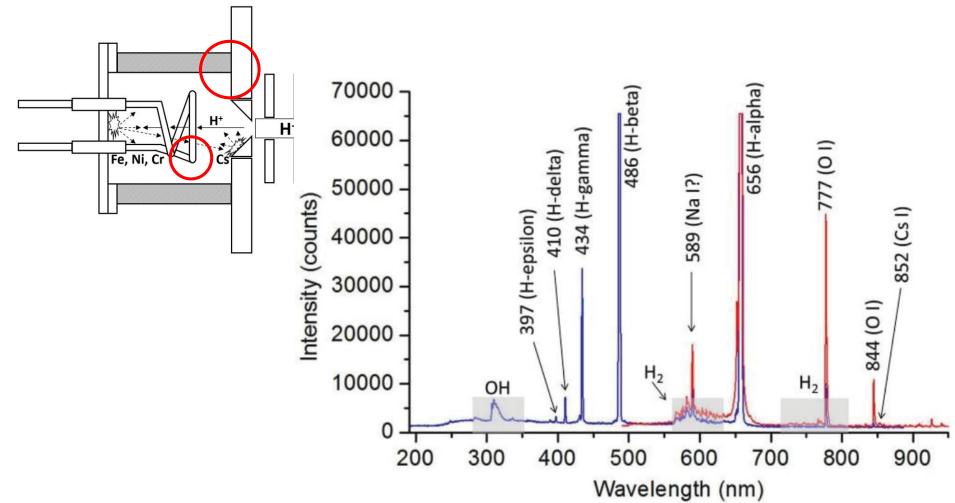
Impurities in a H⁻ source

- Surface collision
 - Sputtering PG
 - Desorption of Cs X⁰
 - Implantation
- Plasma-wall energy exchange
 - Thermalization
 - Collisions with H⁻
 - Adsorption
 - Electron injection
- Sheath formation
 - Magnetic field
 - Potential profile

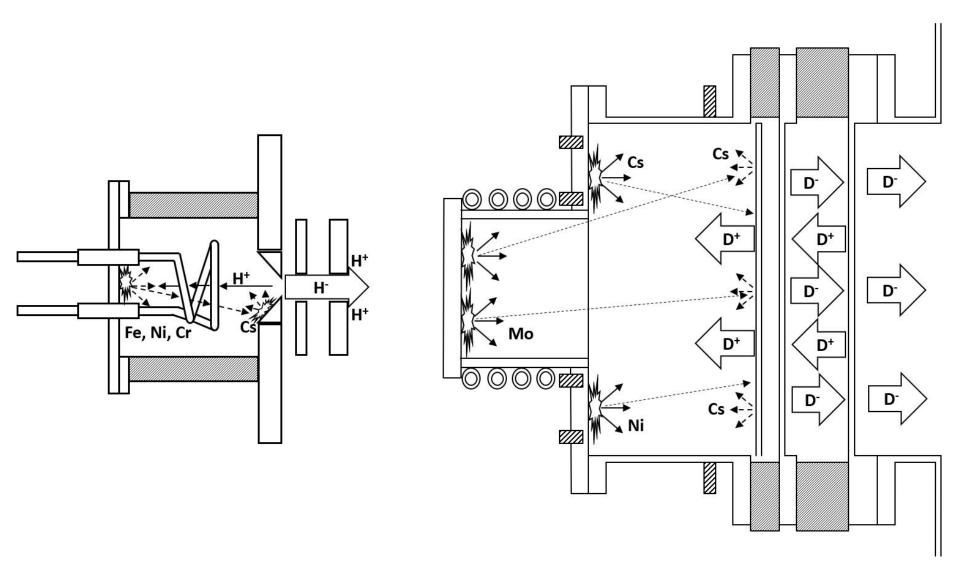


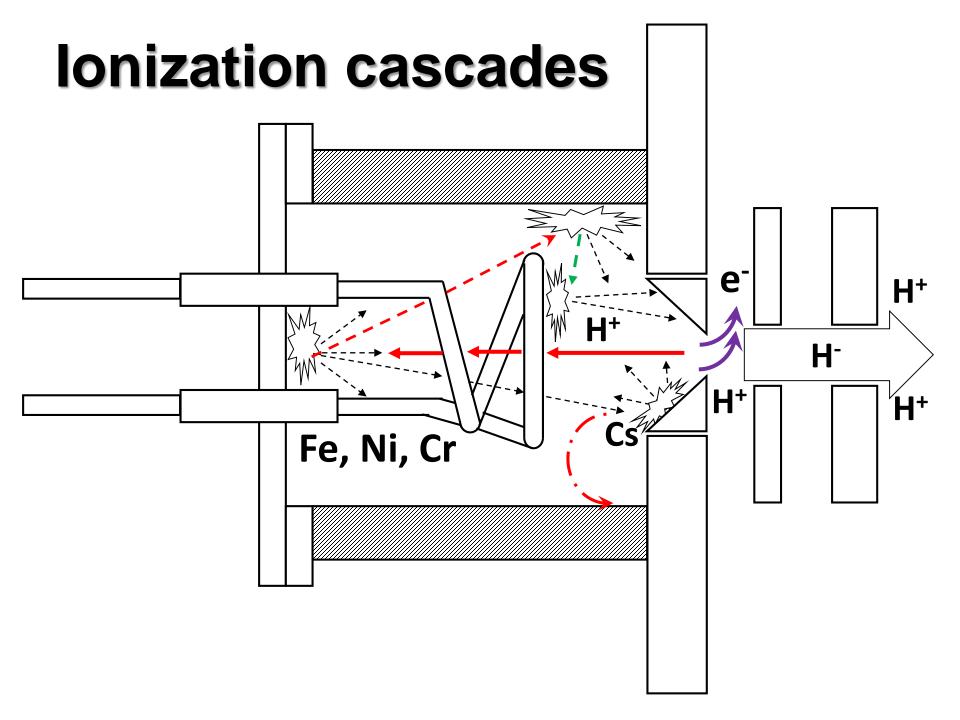
Source of impurities

B.X. Han, R.F. Welton, S.N. Murray Jr., T.R. Pennisi, M. Santana, and M.P. Stockli, "OPTICAL EMISSION SPECTROSCOPY STUDIES OF THE SPALLATION NEUTRON SOURCE (SNS) H⁻ ION SOURCE", Proceedings of IPAC2012, TUPPD048, New Orleans, Louisiana, USA (2012).



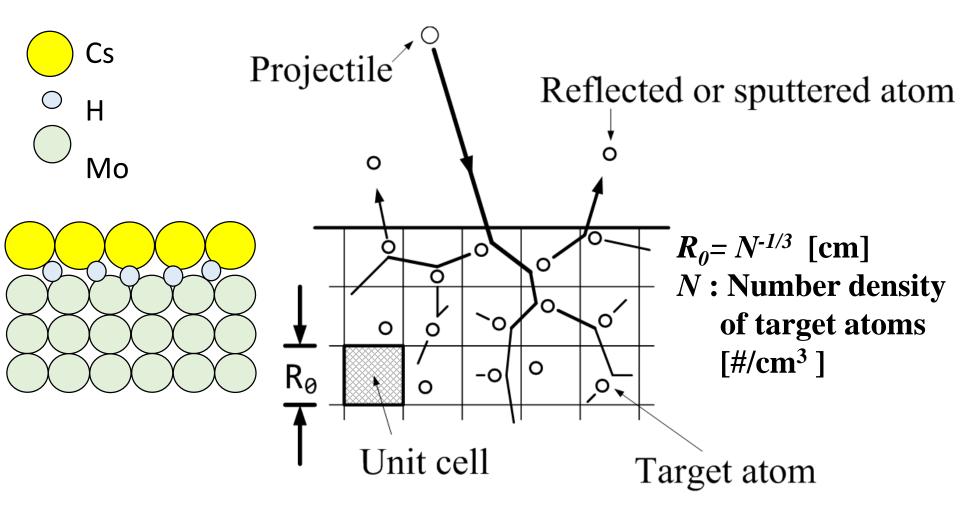
Two configurations

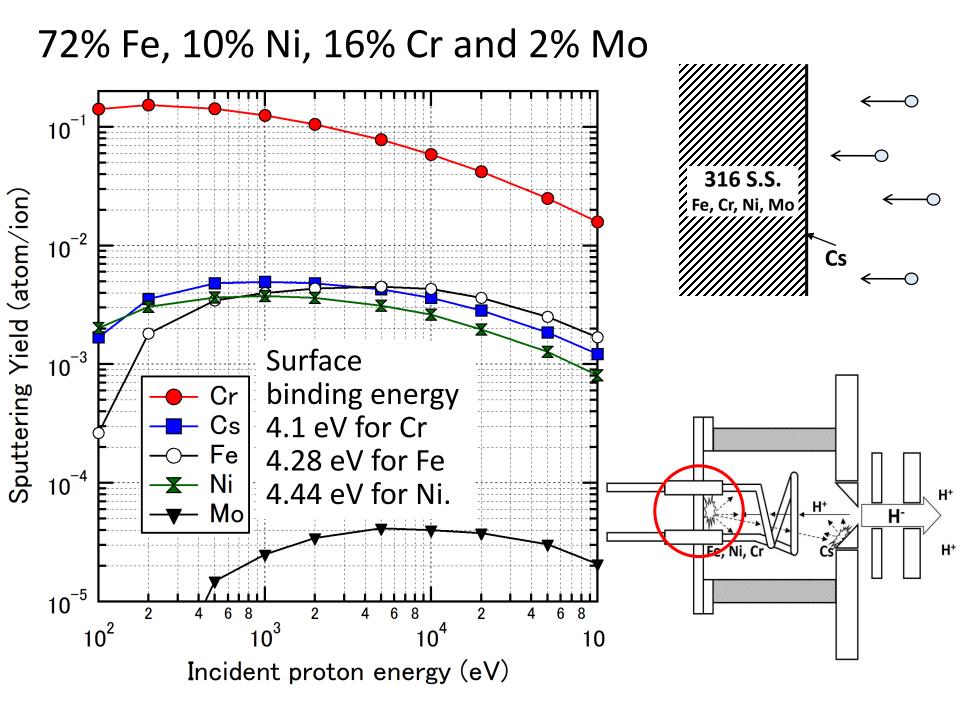


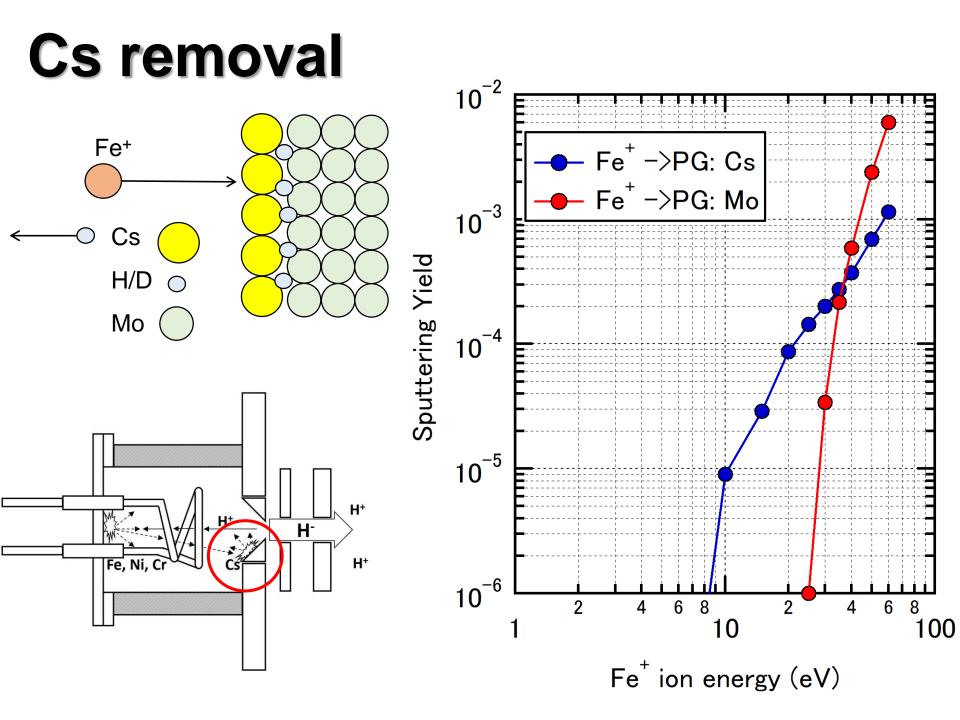


Treatment of the adsorbed layer

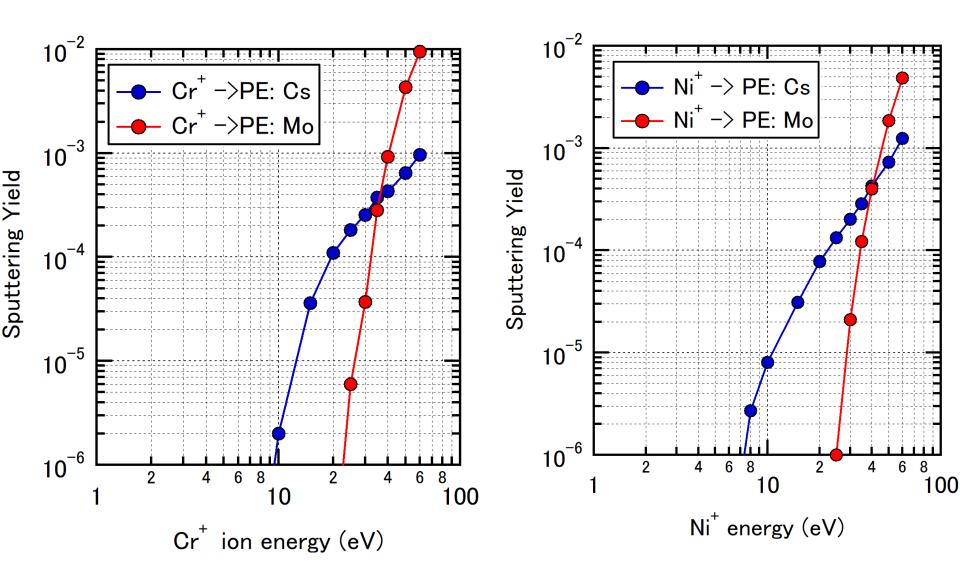
- Both adsorption and retention form interlayers.
- ACAT configures nucleus location by layers.
- Empty site/vacancy are generated by random number.

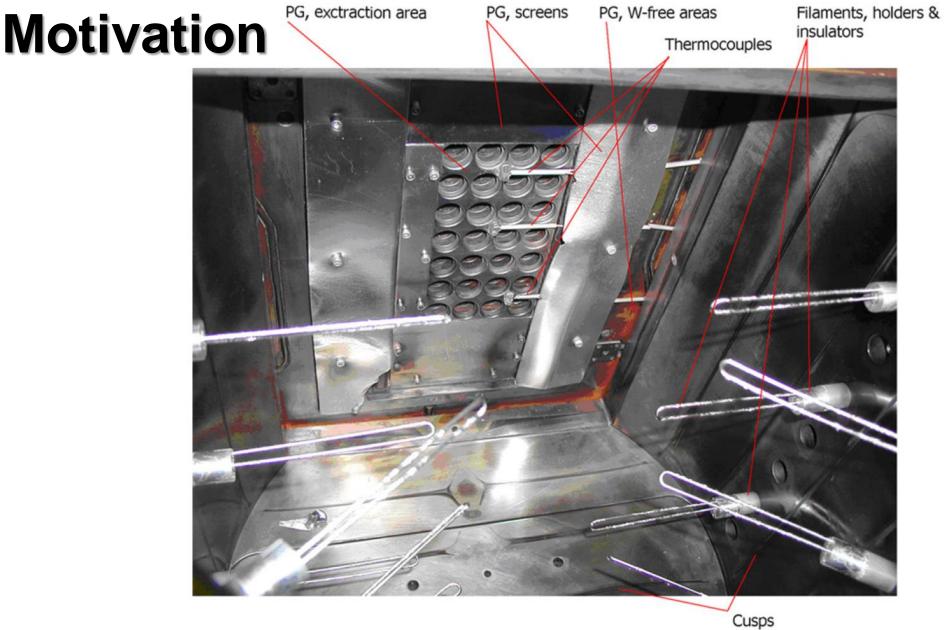






Small difference





A. Krylov, D. Boilson, U. Fantz, R.S. Hemsworth, O. Provitina, S. Pontremoli and B. Zaniol, "Caesium and tungsten behaviour in the filamented arc driven Kamaboko-III negative ion source", Nucl. Fusion 46, S324(2006).

Cu found in the source

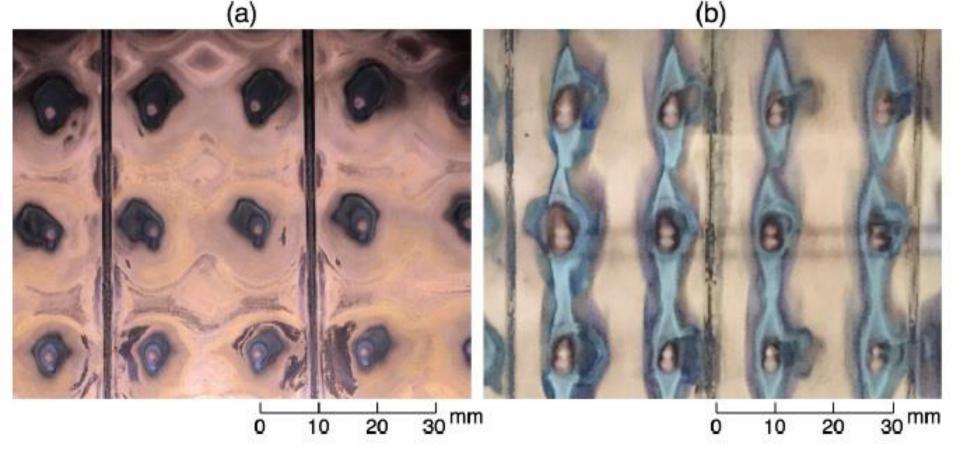
	Cs	W	Cu	Ca	Mo	Fe
Mass (mg) in the area indicated. First row is from the solution, the second from the sediment						
PG extraction area	150	58.5	1.2	6.3	2.7	
	2.84	76.9	12	3.06	0.189	0.473
PG periphery (frame) ^b	2400	310	3	21	8	
	7.58	15.6	32.5	1.86	0.031	0.162
Arc chamber walls	6000	1250	8	7	30	
	13.8	46.6	18.2	2.82	0.123	0.159
Total (g)	8.6	1.8	0.07	0.04	0.04	0.001
Surface density in the area indicated (atom/cm ²)						
PG extraction	2.5E + 18	1.6E + 18	4.5E + 17	5.1E + 17	6.6E + 16	1.8E + 16
PG periphery	1.3E + 19	1.3E + 18	4.0E + 17	4.1E + 17	5.9E + 16	2.1E + 15
Arc chamber	4.9E + 18	7.5E + 17	4.4E + 16	2.6E + 16	3.3E + 16	3.0E + 14

 Table 1. Surface coverage in the Kamaboko III ion source.

^a Traces of Cr, Na, Mg and Si were also found.

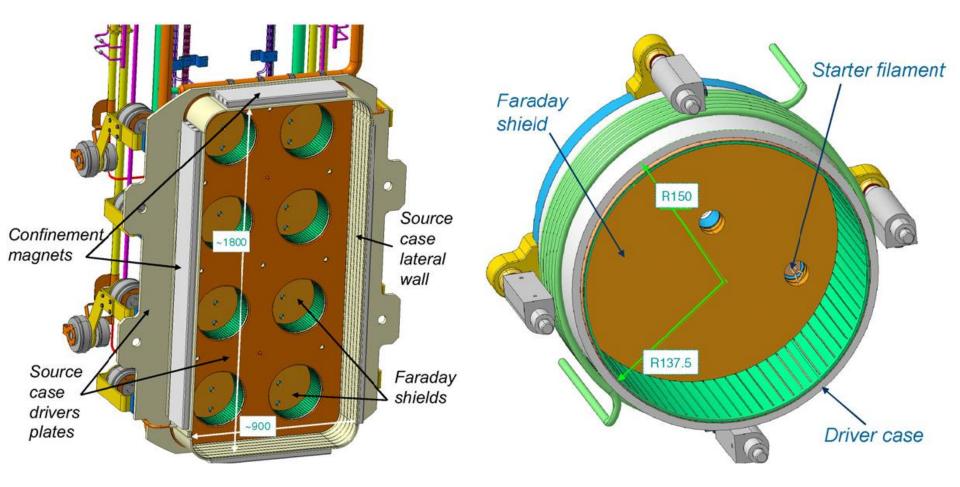
^b For this campaign there were no side masks on the PG. (The side masks are shown in figure 1).

Back streaming ion foot print: NIFS source

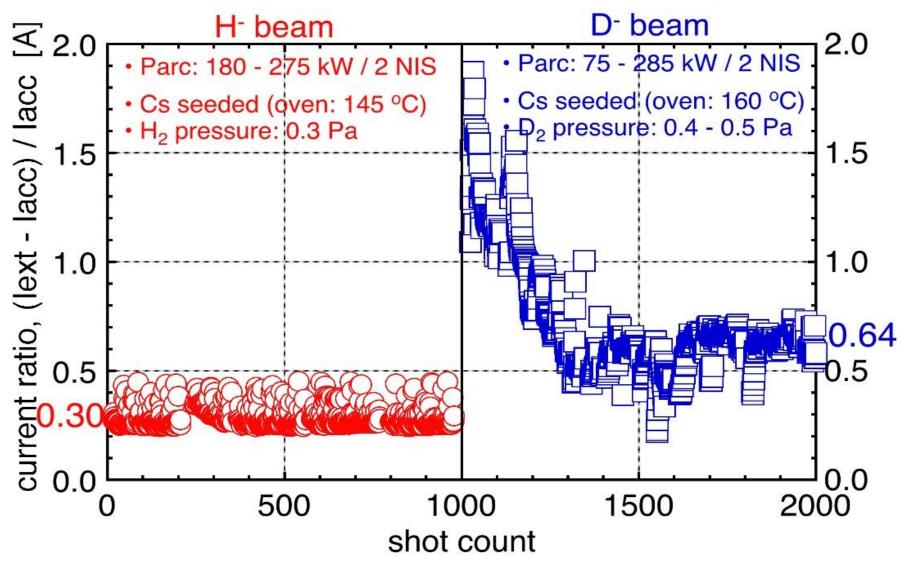


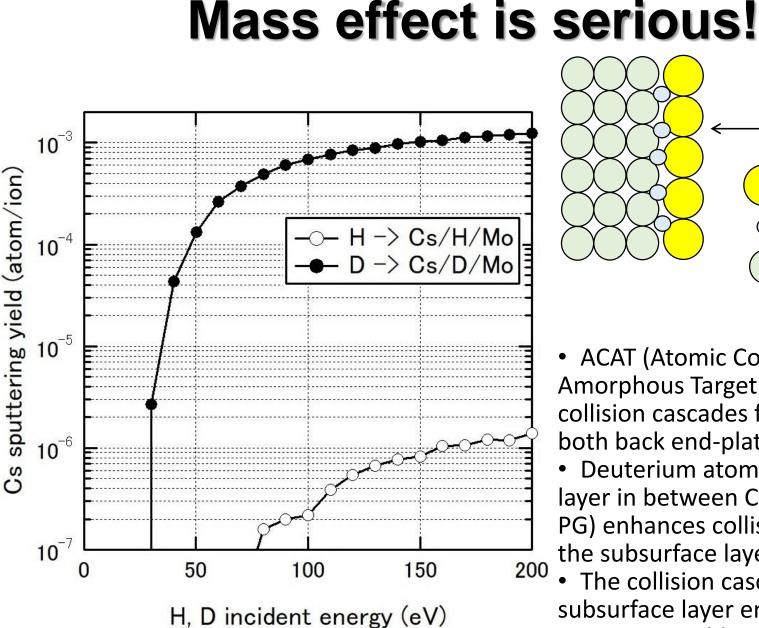
K. Ikeda, M. Kisaki, H. Nakano, K. Nagaoka, M. Osakabe, S. Kamio, K. Tsumori, S. Geng, Y. Takeiri, AIP Conference Proceedings 1869, 050004 (2017).

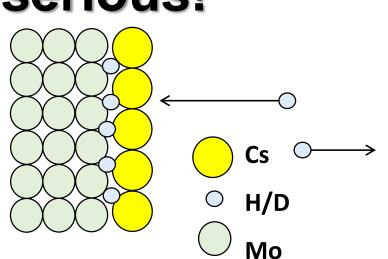
Mo/Ni coatings to reduce sputtering yields



Observation of higher Cs consumption rate



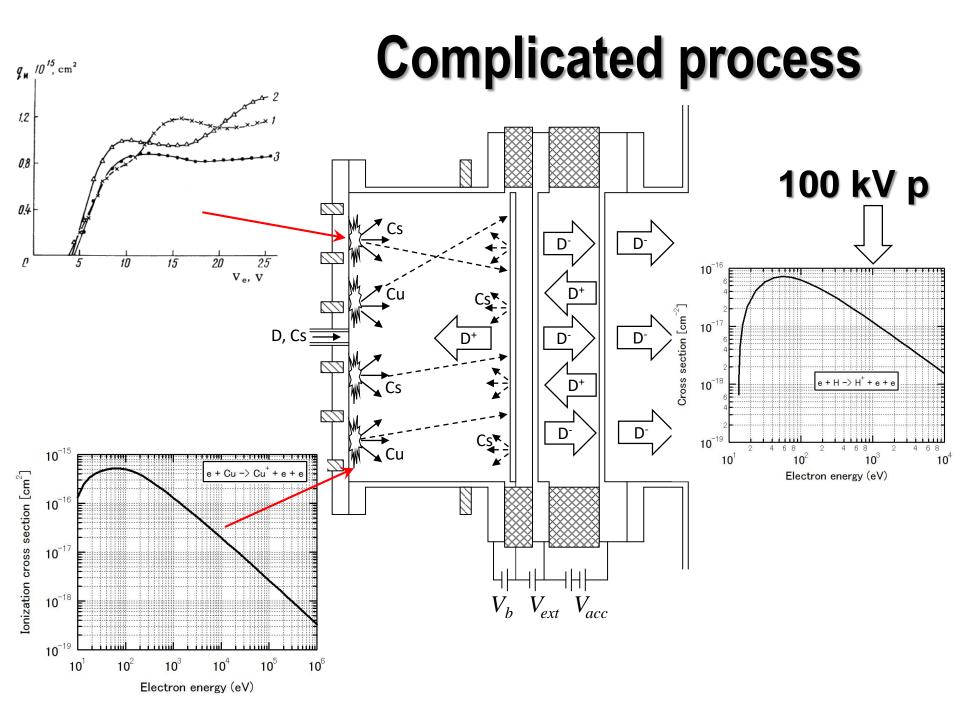


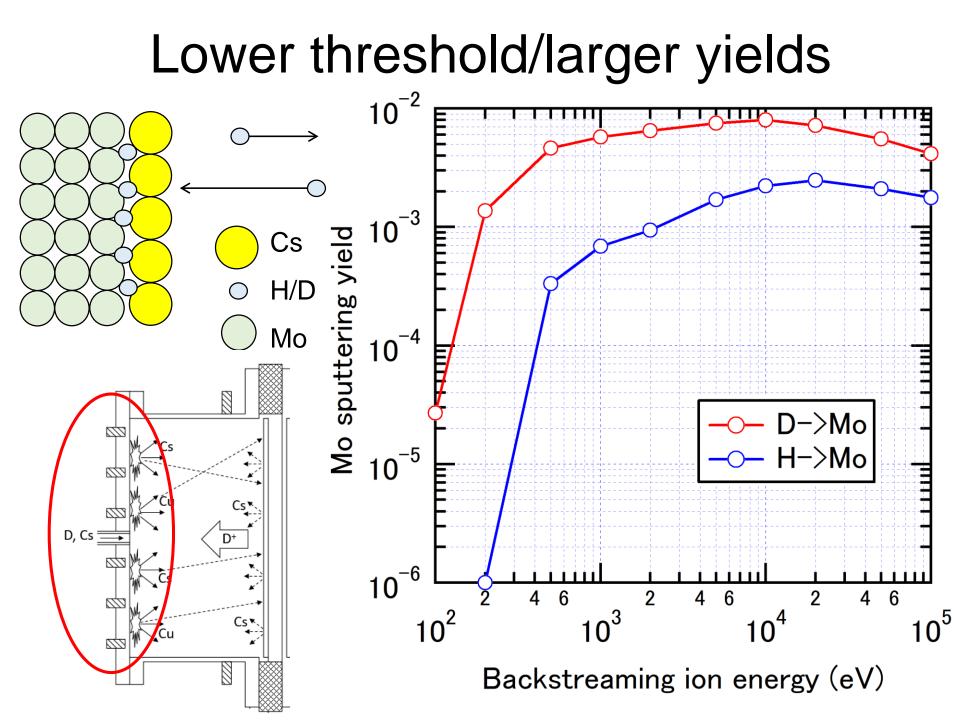


 ACAT (Atomic Collision in Amorphous Target) computed collision cascades for both the both back end-plate and the PG.

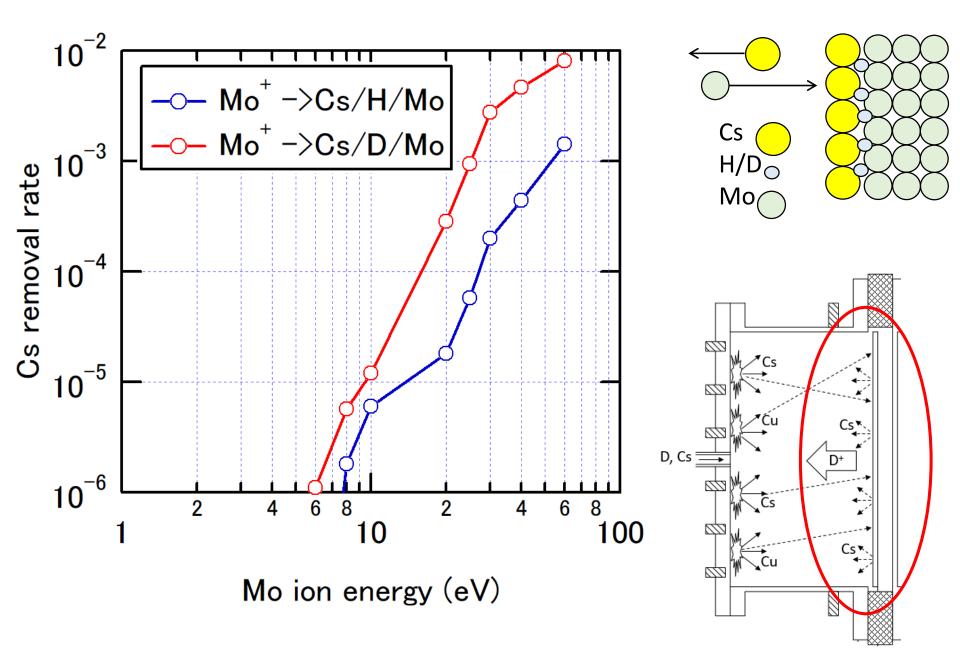
 Deuterium atoms occupying the layer in between Cs and Mo (bulk PG) enhances collision cascade in the subsurface layer.

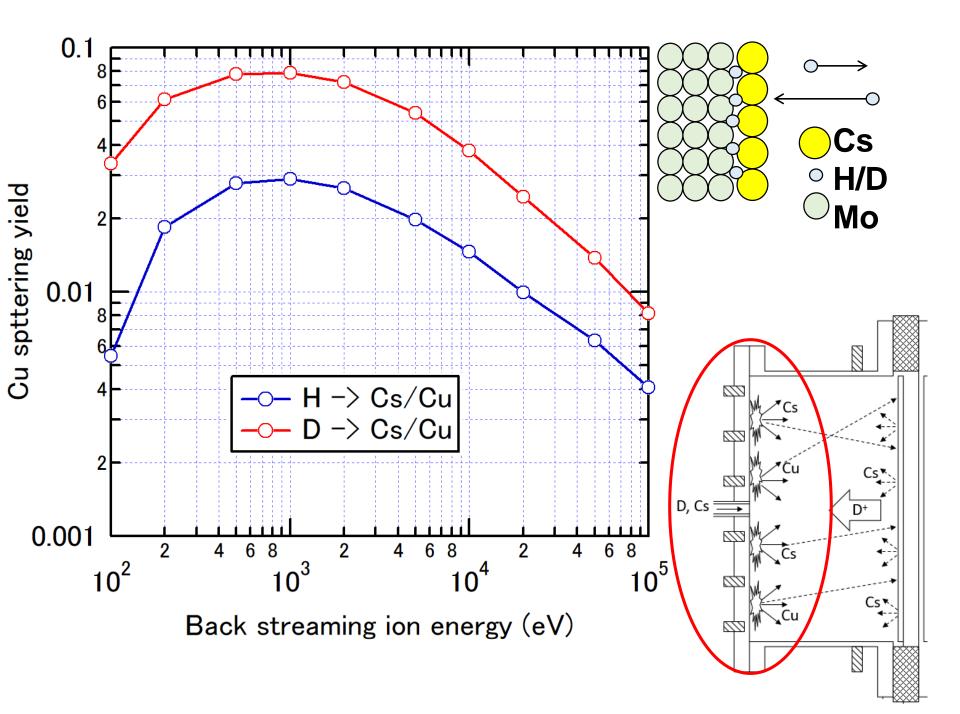
• The collision cascade in the subsurface layer enlarges Cs sputtering yields; more Cs is lost in deuterium discharge.

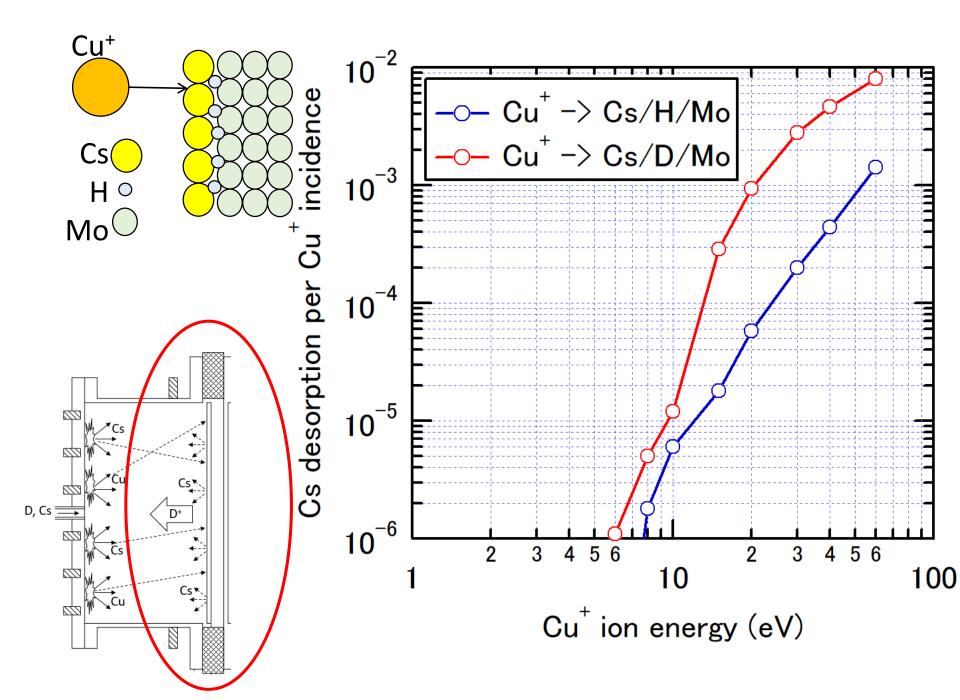


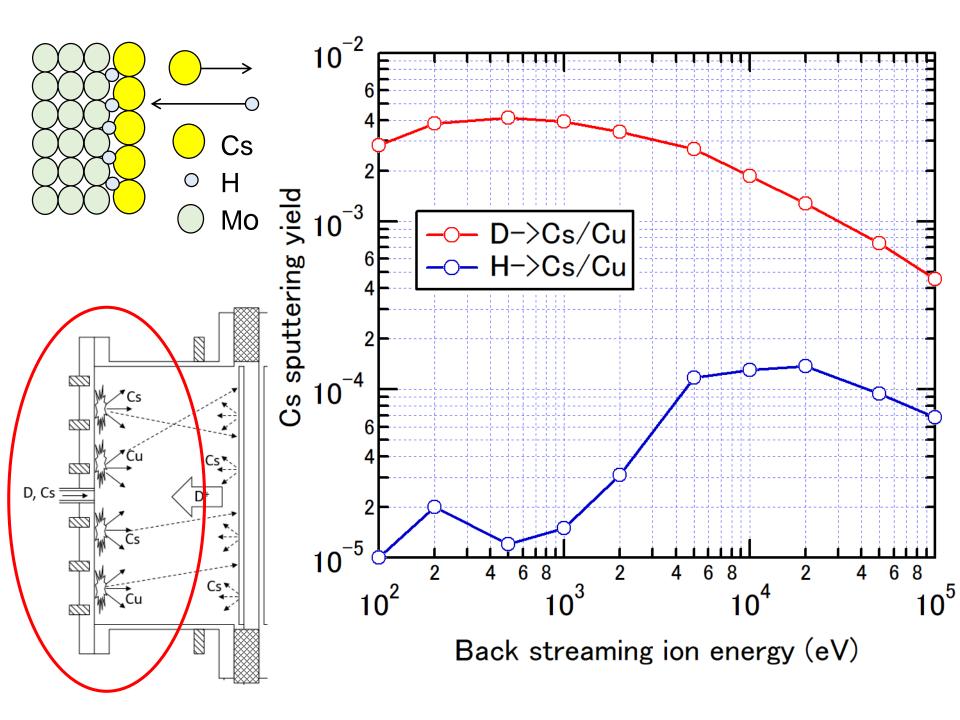


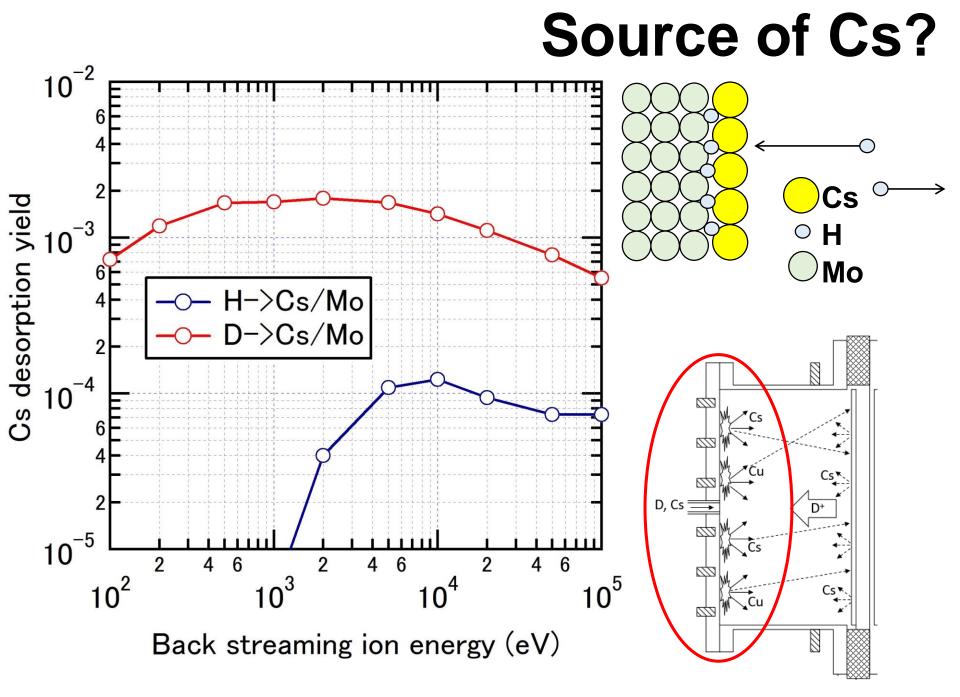
Faster removal



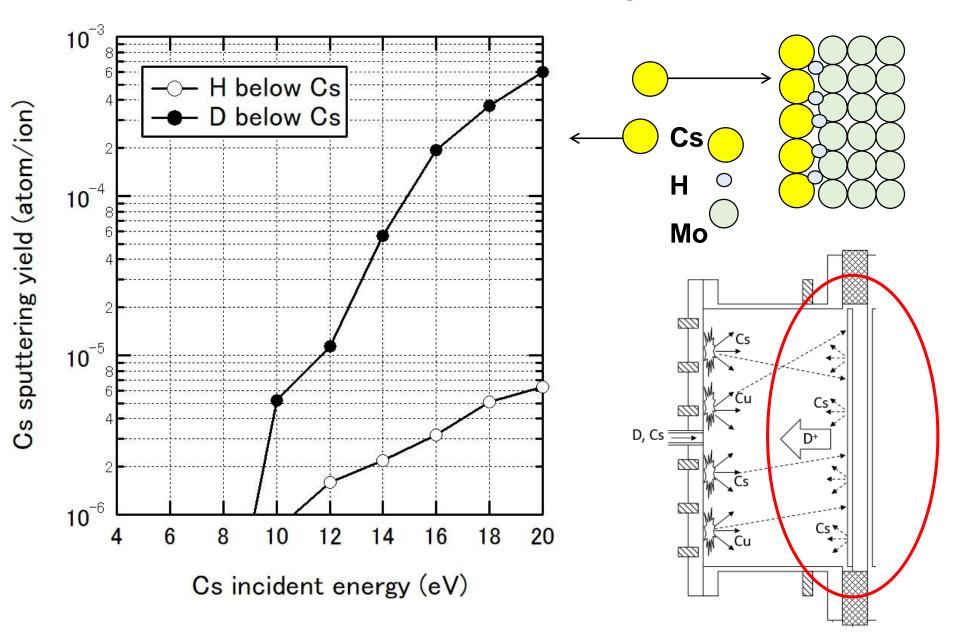




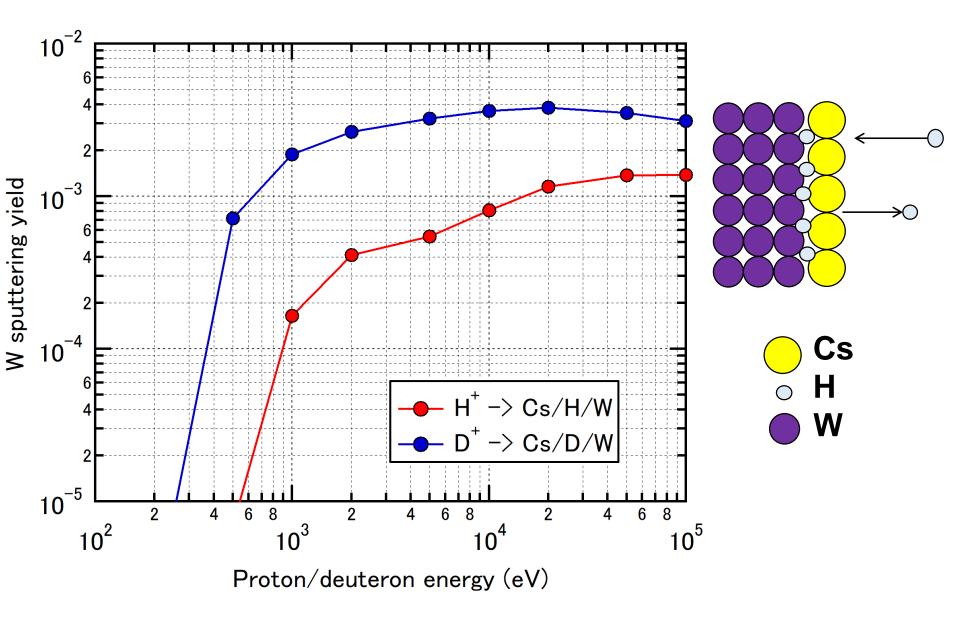


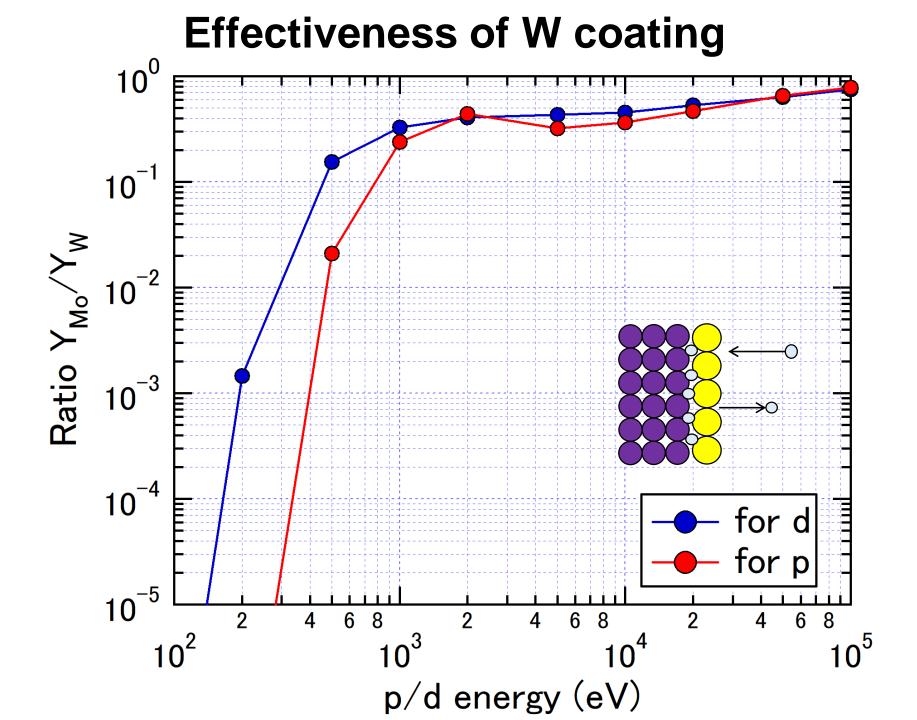


Cs self-sputtering effect



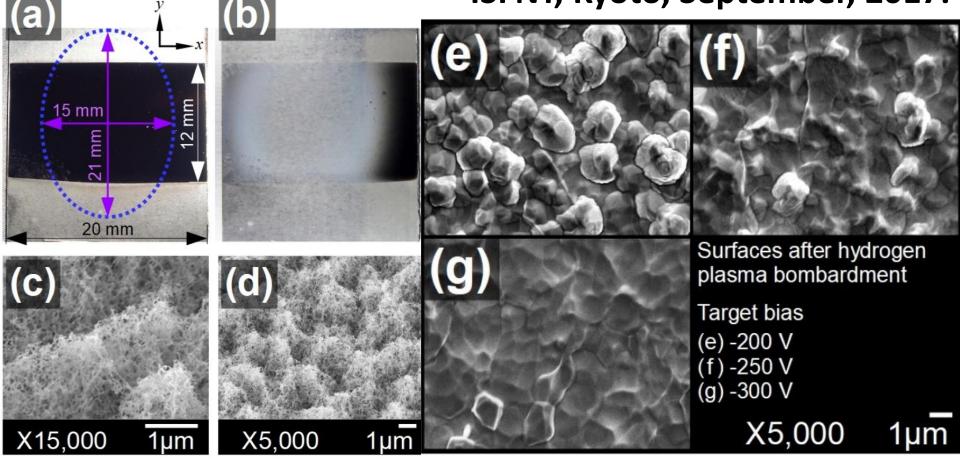
W Coatings on source components



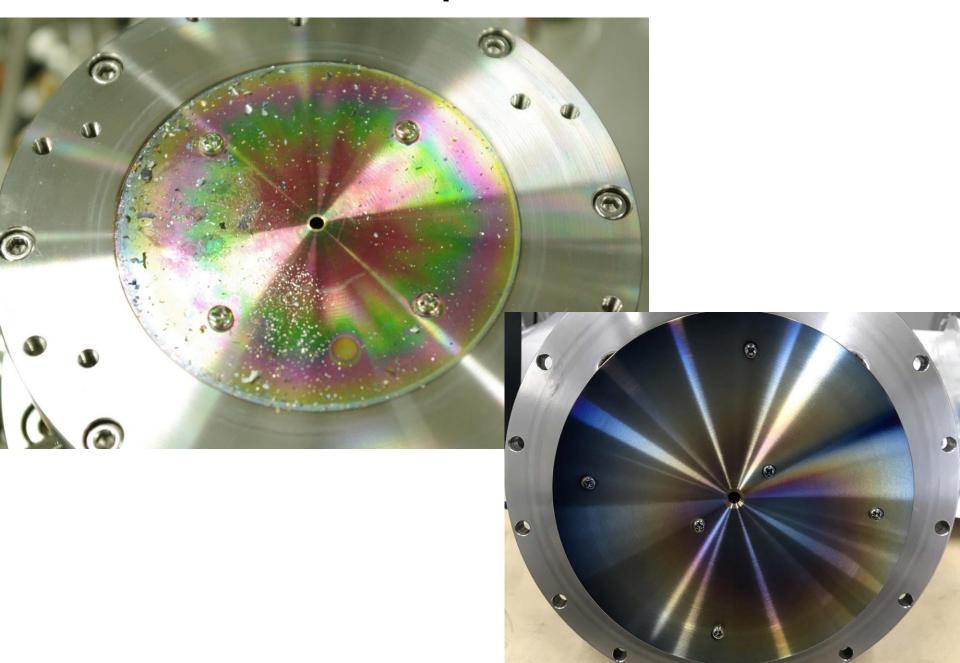


Fuzzy diverter surface

Kenta Doi et al., presented at 13th ISFNT, Kyoto, September, 2017.



Dusts and deposits on the wall



Summary

- Austenitic stainless steel preferentially emits Cr under a bombardment of energetic protons.
- Impurity ions released from stainless-steel wall can remove Cs with 10 eV incident energy. Any potential difference between the plasma electrode and the plasma potential above 10 V can cause sputtering.
- Magnitude of back-streaming positive ion current should be properly evaluated to estimate the effect upon impurity emission.
- Copper exhibits high sputtering yields against protons and deuterons above 100 eV incident energy. Coating the Faraday shield surface with Mo will reduce impurity emission.
- Coating the Faraday shield with W may reduce the impurity emission even smaller.

